

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Yasuo FUKUDA et al.
Appl. No. : Not yet assigned
Filed : Concurrently herewith
For : EPITAXIAL WAFER AND METHOD FOR PRODUCING SAME

Group Art Unit : Not yet assigned
Examiner : Not yet assigned
Confirmation No. : Not yet assigned

AUTHORIZATION TO CHARGE DEPOSIT ACCOUNT

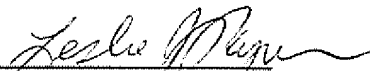
Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop _____
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir :

The undersigned hereby authorizes the U.S. Patent and Trademark Office to charge any fees necessary to maintain the pendency of the above-identified application, including any basic filing fees, application size fees, search fees, examination fees, extension of time fees, and claim fees, to Deposit Account No. 19-0089.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,
Yasuo FUKUDA et al.


William S. Boshnick
Reg. No. 44,550

Leslie J. Paperner
Reg. #33329

June 7, 2006
GREENBLUM & BERNSTEIN, P.L.C.
1950 Roland Clarke Place
Reston, VA 20191
(703) 716-1191